



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Application of:

Iwen Chao

Application No.: 10/779,379

Filed: February 12, 2004

For: SEMICONDUCTOR DEVICE WITH
LOW RESISTIVE PATH BARRIER

Examiner: Douglas A. Wille

Art Unit: 2814

Confirmation No.: 8999

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 on the date shown below:

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PO Box 1450
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AMENDMENT AND RESPONSE TO OFFICE ACTION

INTRODUCTORY COMMENTS

Dear Sir:

This communication is submitted in response to the Office Action mailed April 18, 2005 (hereinafter "Office Action"). In this Office Action, claims 1-30 were pending. Claims 1-30 were rejected. Applicant respectfully requests reconsideration of the above-identified application in view of the amendments and remarks to follow.

Amendments to the Claims are reflected in the listing of claims that begin on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.